Supporting Information

Cyclic Voltammetry on Recessed Nanodisk-Array Electrodes Prepared from Track-Etched Polycarbonate Membranes with 10-nm Diameter Pores

D. M. Neluni T. Perera and Takashi Ito*

Figure S1. (a) FE-SEM image of a TEPCM with 10 nm-diameter pores. The contrast of the image was enhanced to clarify the pores. Area around each pore was shown brightly due to charging of the membrane surface. (b) Distribution of pore diameters determined from FE-SEM images measured at three different regions of a TEPCM.